

Karagiorgis, X., Ntagios, M. , Skabara, P. and Dahiya, R. (2022) 3D-printed elastomer foam-based soft capacitive pressure sensors. In: 2022 IEEE International Conference on Flexible and Printable Sensors and Systems (FLEPS), Vienna, Austria, 10-13 July 2022, ISBN 9781665442732

(doi: [10.1109/FLEPS53764.2022.9781553](https://doi.org/10.1109/FLEPS53764.2022.9781553))

This is the Author Accepted Manuscript.

© 2022 IEEE. Personal use of this material is permitted. Permission from IEEE must be obtained for all other uses, in any current or future media, including reprinting/republishing this material for advertising or promotional purposes, creating new collective works, for resale or redistribution to servers or lists, or reuse of any copyrighted component of this work in other works.

There may be differences between this version and the published version. You are advised to consult the publisher's version if you wish to cite from it.

<http://eprints.gla.ac.uk/273319/>

Deposited on: 16 June 2022

3D-printed elastomer foam-based soft capacitive pressure sensors

Xenofon Karagiorgis,^a Markellos Ntagios,^a Peter Skabara^b and Ravinder Dahiya^{a*}

^aBendable Electronics and Sensing Technologies (BEST) Group, School of Engineering, University of Glasgow, UK

^bSchool of Chemistry, University of Glasgow, UK

Corresponding author: Ravinder.Dahiya@glasgow.ac.uk

Abstract—The field of tactile sensing has exploded in recent years with the development of sensors using a wide variety of composite materials and fabrication techniques to meet the varying requirement of applications such as robotics, wearable, and interactive systems. Often these applications require touch sensors over large areas, and this calls for a simple manufacturing route such as additive manufacturing. Herein we present fully 3D printed highly sensitive capacitive touch sensors with an elastomeric foam-based dielectric layer (a blend of PDMS and BaTiO₃) and PEDOT: PSS and AgNWs composite based electrodes. The device is encapsulated with PDMS. The sensor was tested under dynamic and static conditions, and the sensitivity was found to be 0.918 %kPa⁻¹ with excellent linearity (99.77%). The presented approach for realizing soft and flexible electronic skin (e-Skin) in one single automated step has potential to transform applications such as wearables, health monitoring, and rehabilitation with low-cost and easily manufacturable high-performance sensors.

Keywords—tactile sensor, flexible sensors, soft sensor, porous PDMS, direct ink writing, 3D printing

I. INTRODUCTION

Tactile or electronic skin (e-Skin) and touch-based interfaces are widely used in robotic, prostheses, and haptic feedback-based interactive systems[1-4]. Often the e-Skins with tactile sensors are developed in such a way that they can be wrapped around or placed on the external curvy surfaces of these systems and real-world objects [5-7], but recently they have also been embedded in 3D printed smart structures [8], or concealed in wearables such as smart gloves, to prevent wear and tear [9]. Whilst several types of touch sensors have been explored, the ones working on the capacitive transduction method are most popular due to their simple structures and readout electronics [10]. Capacitive-based sensors offer high sensitivity for static or quasi-static contacts in the low-pressure range, which is typically needed in object handling [10-13]. To improve the conformability, soft and stretchable capacitive touch sensors have also been reported recently using elastomeric materials as dielectric or stretchable substrates [14-19]. Most of these sensors rely on traditional microfabrication techniques, such as etching, spin-coating, electroplating, photolithography, etc. Whilst, these methods have helped to obtain high density and spatial resolution e-Skins, they are also time-consuming, costly, and complex. Since many e-Skins applications require touch sensors over large areas, there is a need for a simple manufacturing route such as additive manufacturing (AM).

The AM processes provide an attractive alternative method for the fabrication of transducers and smart structures [20, 21]. Techniques such as fused-Deposition-Modelling (FDM) and direct ink writing (DIW) using multi-material 3D printing show increasing interest. 3D printing allows the

seamless realisation of complex design, structures, and shapes without complicated multi-step processes. New 3D printers have emerged with more sophisticated controls and the possibility to print multi-materials (not just polymers, but also conductive inks and composites). These allow simple manufacturing of devices with higher resolution as well as their integration with readout electronics [8, 22, 23]. This is especially important for DIW printers as the rheological properties of different composites require different printing parameters. These AM systems have been demonstrated to be able to print smart devices and intrinsic sensors.

Herein, we present fully 3D printed highly sensitive capacitive touch sensors with an elastomeric foam-based dielectric layer (a blend of PDMS and BaTiO₃) and PEDOT: PSS and AgNWs composite based electrodes. For soft capacitive tactile sensors, elastomers such as polydimethylsiloxane (PDMS) have been well used as the dielectric because of their good mechanical strength, stretchability, elasticity, and conformability [13, 24-27] along with conductive materials such as PEDOT: PSS and conductive fabric [3, 27]. However, the sensitivity of bulk PDMS structures is insufficient for fine texture detection, and as a result, a blend of PDMS and other high dielectric materials such as barium titanate [28], zirconium [29], and ZnO nanowires [18], *etc.* have been used to improve performance [26]. In parallel, porous PDMS active layers have also been explored. The porous structures in these cases have been obtained using sodium chloride (NaCl), sugar cubes, potassium chloride (KCl), and ammonium bicarbonate (NH₄HCO₃) to improve further the sensor's sensitivity [30-32]. Building on these advances, here we have an innovative 3D printing approach to develop capacitive pressure sensors with 3D printing of a dielectric layer based on porous PDMS and BaTiO₃. The sensors are developed with porous layers at a weight ratio of PDMS: NH₄HCO₃: BaTiO₃ 80:20:1 and 16:4:1. The results, presented in this paper, showcase the exceptional characteristics of the porous layers and the influence of the different concentrations of BaTiO₃ on the capacitive responses of the sensors.

This paper is organised as follows: Section II describes the materials and the fabrication procedure used for the capacitive sensors. Section III explains the experimental process and performance of the 3D printed devices. Section IV summarizes the results.

II. MATERIALS AND METHODS

A. Design of the capacitive sensor

Fig. 1 shows the design of the sensor and its fabrication by DIW. The device has two electrodes that are 20 mm wide, 15 mm long, 0.5 mm thick, and an extended square contact pad of 5 mm. The dielectric layer has the same design as the electrodes. The device was encapsulated with PDMS in a

This work was supported in part by the Engineering and Physical Sciences Research Council through Engineering Fellowship for Growth (EP/R029644/1) and Heteroprint Programme Grant (EP/R03480X/1).

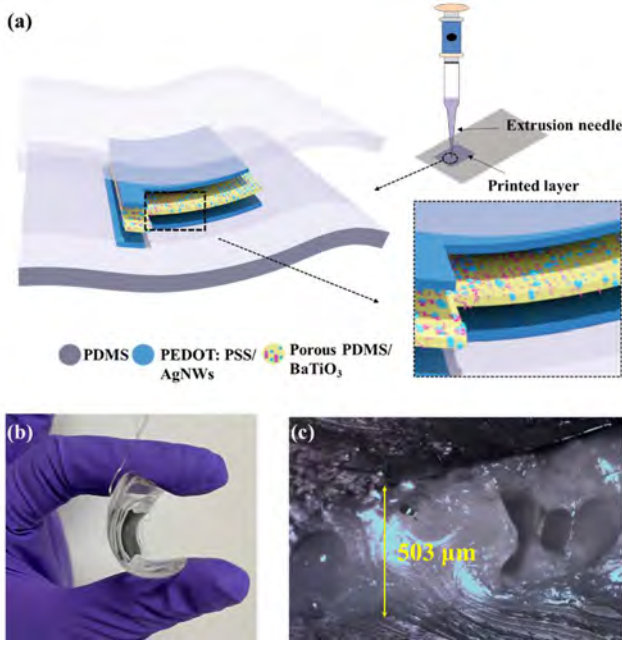


Fig. 1. (a) Schematic illustration of the sensor's design and printing of various layers, (b) 3D printed flexible capacitive sensor and (c) microscopic image of the dielectric layer.

square pattern of 30×30 mm. The thickness of the entire device is 20.15 mm.

B. Material Preparation

1) *Dielectric Layer*: The curing agent was mixed with the PDMS prepolymer (the weight ratio of prepolymer and curing agent is 10:1). After mixing, the PDMS was placed in the desiccator to eliminate its bubbles. Bulk PDMS was used for the encapsulation of the device, while a portion of that was used as the matrix for the porous dielectric layer. The porous PDMS was obtained by mixing bulk PDMS with 1 wt. % NH_4HCO_3 and stirring the solution for 5 minutes. The BaTiO_3 was also added to the PDMS: NH_4HCO_3 solution. Two different ratios of BaTiO_3 were added to porous PDMS to develop Sensor1 (1 wt. % of BaTiO_3) and Sensor2 (5 wt. % of BaTiO_3). Fig. 2a illustrates the preparation of the solution for the dielectric layer.

2) *Electrode*: 1 wt. % of polyethylene oxide (PEO) was added to the PEDOT: PSS solution and was stirred at room temperature until PEO was dissolved. After that, 10 % (v/v) of DMSO was added to the conductive solution to improve the conductivity of the ink. The solution was stirred for 1 hour at 200 rpm at room temperature until the dopant was well-dispersed. Lastly, 2 % (v/v) of AgNWs were added. The ink was stirred for another 30 minutes at ambient temperature to achieve uniformity. Fig. 2b presents the preparation process for the conductive ink used here to form the electrodes.

C. Device Fabrication

The five-layer device was fabricated using DIW techniques. The 3D printer used in this study is a state-of-the-art 3D printer (Brinter, Turku, Finland) able to print paste-like materials. Firstly, the PDMS (top and bottom layers) of the device were printed on a heated printed bed at 80°C . The PDMS was filled in a syringe with 18G nozzle size (internal diameter of 0.84 mm), and the system was able to deposit the material at a pressure of 500 mbar. When the PDMS layers

were cured, a syringe with the conductive ink was placed in the pneumatic printing tool (from Brinter) to print on top of the two PDMS layers. For the conductive ink, 120 mbar was applied using a 21G nozzle (internal diameter of 0.51 mm). When the conductive layers were dried, the syringe was filled with the porous PDMS/ BaTiO_3 mixture solution. This solution was printed on top of only one of the two electrodes, using a 14G nozzle (internal diameter of 1.54 mm). Two different pressures were applied to obtain two dielectric layers with different concentrations of BaTiO_3 in porous PDMS. More specifically, 3000, and 5000 mbar were applied to print the porous mixture with 1% and 5% wt of BaTiO_3 , respectively. Immediately after the printing, the structures were placed in the oven for 1 hour at 90°C to enable the formation of pores. When NH_4HCO_3 is heated, it decomposes into carbon dioxide (CO_2), ammonia (NH_3), and water (H_2O) [24, 30]. Eq. 1 illustrates the decomposition of the annealed NH_4HCO_3 at 90°C in an endothermic process. After this the structure with the porous layer and the one without it, were attached and bonded together with a small amount of PDMS on the edges. Copper wires on the side of the top and bottom electrodes were attached with silver paste and epoxy resin.



III. RESULTS AND DISCUSSION

A. Performance and Evaluation

The fabricated devices were tested for their transducer characteristics. All the experiments were conducted using a linear actuator that applied controlled pressure to the devices. The actuator was controlled by custom-made LabVIEW software. The sensors were placed on top of a load cell to measure the forces applied by the linear motor. A circular

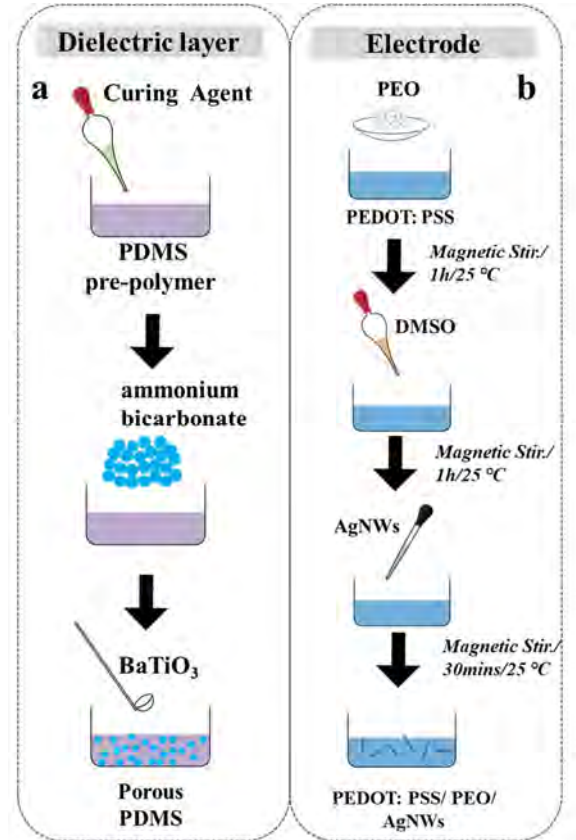


Fig. 2. Schematic illustration of the preparation of solutions for various layers needed in the sensor.

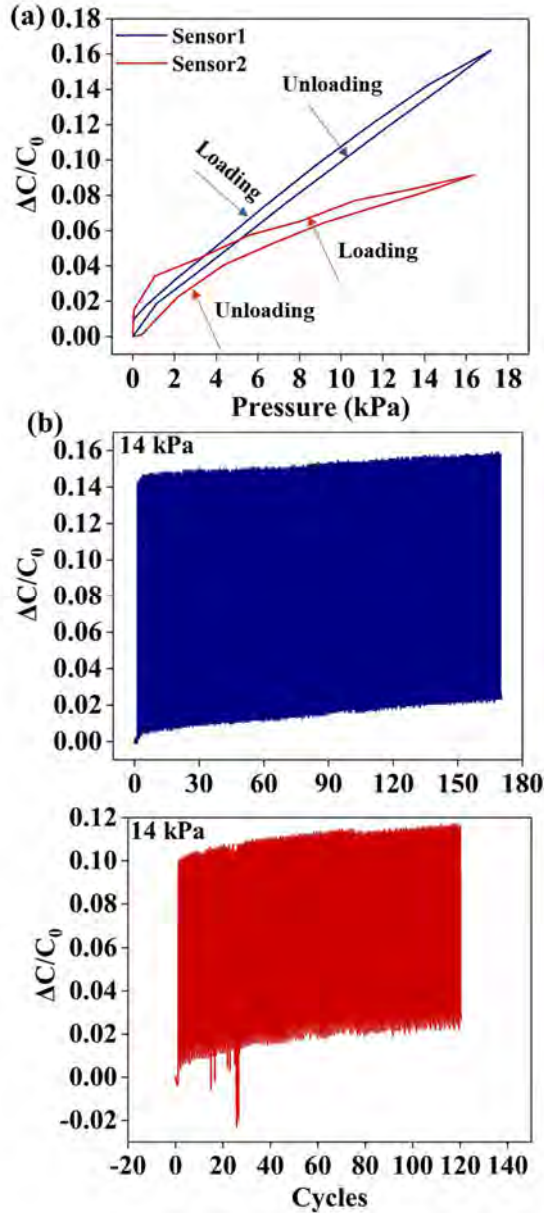


Fig. 3. (a) Capacitive responses under different loading and unloading conditions and the stability of sensors over time for (b) Sensor1 and (c) Sensor2.

probe was attached to the linear motor with a diameter of 2 cm and that was the object in contact with the device. The change in the capacitance was measured using a Keysight (E4980AL) LCR meter.

The devices were tested for their response to static stimuli. In that regard, the devices were tested for pressure between 0-17 kPa. Fig. 3a presents the relative change of capacitance with respect to applied pressure under loading and unloading conditions. From the results, it may be noted that Sensor1 exhibited a sensitivity of $0.918\%/\text{kPa}^{-1}$ (with linearity (R^2) of 0.99768), and Sensor2 showed a considerably lower sensitivity of $0.556\%/\text{kPa}^{-1}$ (with a slightly less linear fit of 0.95856). In order to observe the stability of the sensors, dynamic stimuli were applied, and the response was recorded. Fig. 3 (b-c) presents the relative change of capacitance with respect to pressure loading-unloading cycles. The devices were tested for 120 cycles with each cycle lasting for 3 s. The pressure was applied from 0 to 14 kPa. From the experimentation, we can conclude that the devices show a minor deviation (0.587% for Sensor1 and 0.663% for

Sensor2) from one cycle to the following one with a slight upwards trend. This can be attributed to the viscoelastic creep effect that PDMS possesses [33]. Sensor2 showed some inconsistency for some of the cycles at the beginning of the measurements.

TABLE I. SUMMARY CHARACTERISTICS OF EACH SENSOR

Sensor	Hysteresis [%]	Linearity [%]	Standard Deviation [%]	Sensitivity [%/kPa]
1	1.427	99.77	0.587	0.918
2	5.83	95.58	0.663	0.556

Table I summarizes the characteristics of the two pressure sensors. The hysteresis showed by Sensor1 was found to be 1.427% and 5.83% for Sensor2, calculated using the reported method [30]. Each sensor's response also varies (Fig. 3a), especially with increasing pressure. This difference in the response can be explained by the porosity of the dielectric layers in each device. The porous layer of Sensor1 consisted of a larger number of pores than the porous layer of Sensor2. The addition of BaTiO_3 improves the capacitive responses of the sensors due to its high dielectric constant [28, 34]. However, it occupies some of the area in the PDMS matrix, when the porous layer is annealed to form the pores, resulting in a less porous structure. In other words, BaTiO_3 creates an agglomeration in the PDMS matrix which reduced the compressibility of the dielectric material. This explains the difference in the response of each device. Moreover, since Sensor1 consisted of a more porous dielectric layer, it has a lower Young's Modulus, which improved the sensitivity [30].

Table II presents the comparison of the performance of devices developed using our approach with other works reported in the literature. This includes devices developed using different fabrication techniques. The data clearly show that Sensor1 has much greater sensitivity in this series of devices, with the next best-performing device being twofold less sensitivity.

TABLE II. COMPARATIVE TABLE

Fabrication Method	Dielectric Layer	Sensitivity [% kPa^{-1}]
SLS [35]	CNT-TOU	0.549 (17-100 kPa) 0.146 (100-240 kPa) 0.035 (240-515 kPa)
DIW[36]	Graphene Nanoplates (GNPs)/MWCNT	0.164 (>70 kPa)
FDM [8]	Ecoflex 00-30	0.348 (>10 kPa) 0.134 (<50 kPa)
Drop-casting [34]	Porous PDMS	0.18 (0-400 kPa)
Drop-casting [37]	CNF/Porous PDMS	0.60 (0-1kPa)
Drop Casting [38]	Porous PDMS	0.0083 (4-200 Pa) 0.0124 (44 Pa-2 kPa) 0.0012 (2.2-120 kPa)
DIW [39]	PDMS	0.31 (0.248-500 kPa)
DIW [This work]	Porous PDMS/BaTiO_3	0.918 (>20 kPa)

IV. CONCLUSION

This paper presents fully 3D-printed capacitive touch or pressure sensing devices, based on a porous dielectric layer. The first fully printed porous PDMS based sensor exhibited high sensitivity, stability, and low hysteresis. In the future, devices with different ratios of porous PDMS: BaTiO_3 will be printed to deeply examine the effect of BaTiO_3 in the sensor's response.

REFERENCES

- [1] P. Karipoth, A. Pullanchiyodan, A. Christou, and R. Dahiya, "Graphite-Based Bioinspired Piezoresistive Soft Strain Sensors with Performance Optimized for Low Strain Values," *ACS Applied Materials & Interfaces*, vol. 13, no. 51, pp. 61610-61619, 2021.
- [2] R. Mukherjee, P. Ganguly, and R. Dahiya, "Bioinspired Distributed Energy in Robotics and Enabling Technologies," *Advanced Intelligent Systems*, p. 2100036, 2021, doi: <https://doi.org/10.1002/aisy.202100036>.
- [3] M. Bhattacharjee, M. Soni, P. Escobedo, and R. Dahiya, "PEDOT:PSS Microchannel-Based Highly Sensitive Stretchable Strain Sensor," *Advanced Electronic Materials*, vol. 6, no. 8, p. 2000445, 2020.
- [4] R. Dahiya, "E-Skin: From Humanoids to Humans [Point of View]," *Proceedings of the IEEE*, vol. 107, no. 2, pp. 247-252, 2019.
- [5] J. Case, M. Yuen, M. Mohammed, and R. Kramer, "Sensor Skins: An Overview," in *Stretchable Bioelectronics for Medical Devices and Systems*, J. A. Rogers, R. Ghaffari, and D.-H. Kim Eds. Cham: Springer International Publishing, 2016, pp. 173-191.
- [6] O. Ozioko, P. Karipoth, P. Escobedo, M. Ntagios, A. Pullanchiyodan, and R. Dahiya, "SensAct: The Soft and Squishy Tactile Sensor with Integrated Flexible Actuator," *Advanced Intelligent Systems*, vol. 3, no. 3, p. 1900145, 2021.
- [7] P. Escobedo, M. Ntagios, D. Shakthivel, W. T. Navaraj, and R. Dahiya, "Energy Generating Electronic Skin With Intrinsic Tactile Sensing Without Touch Sensors," *IEEE Transactions on Robotics*, vol. 37, no. 2, pp. 683-690, 2021.
- [8] M. Ntagios, H. Nassar, A. Pullanchiyodan, W. T. Navaraj, and R. Dahiya, "Robotic Hands with Intrinsic Tactile Sensing via 3D Printed Soft Pressure Sensors," *Advanced Intelligent Systems*, vol. 2, no. 6, p. 1900080, 2020.
- [9] O. Ozioko and R. Dahiya, "Smart Tactile Gloves for Haptic Interaction, Communication, and Rehabilitation," *Advanced Intelligent Systems*, p. 2100091, 2021.
- [10] R. S. Dahiya and M. Valle, *Robotic tactile sensing: technologies and system*. Springer, 2013.
- [11] V. Palaniappan et al., "A Porous Microstructured Dielectric Layer Based Pressure Sensor for Wearable Applications," in *2021 IEEE International Conference on Flexible and Printable Sensors and Systems (FLEPS)*, 2021, pp. 1-4.
- [12] T.-D. Nguyen and J. S. Lee, "Recent Development of Flexible Tactile Sensors and Their Applications," *Sensors*, vol. 22, no. 1, 2022.
- [13] Y. Kumaresan, O. Ozioko, and R. Dahiya, "Multifunctional Electronic Skin With a Stack of Temperature and Pressure Sensor Arrays," *IEEE Sensors Journal*, vol. 21, no. 23, pp. 26243-26251, 2021.
- [14] C.-C. Chiang, C.-C. K. Lin, and M.-S. Ju, "An implantable capacitive pressure sensor for biomedical applications," *Sensors and Actuators A: Physical*, vol. 134, no. 2, pp. 382-388, 2007.
- [15] S. W. Park, P. S. Das, A. Chhetry, and J. Y. Park, "A Flexible Capacitive Pressure Sensor for Wearable Respiration Monitoring System," *IEEE Sensors Journal*, vol. 17, no. 20, pp. 6558-6564, 2017.
- [16] A. Chhetry, H. Yoon, and J. Y. Park, "A flexible and highly sensitive capacitive pressure sensor based on conductive fibers with a microporous dielectric for wearable electronics," *Journal of Materials Chemistry C*, vol. 5, no. 38, pp. 10068-10076, 2017.
- [17] K. Lee et al., "Rough-Surface-Enabled Capacitive Pressure Sensors with 3D Touch Capability," *Small*, vol. 13, no. 43, p. 1700368, 2017.
- [18] Y. Kumaresan, S. Ma, O. Ozioko, and R. Dahiya, "Soft Capacitive Pressure Sensor with Enhanced Sensitivity assisted by ZnO NW Interlayers and Airgap," *IEEE Sensors Journal*, pp. 1-1, 2022, doi: [10.1109/JSEN.2022.3143030](https://doi.org/10.1109/JSEN.2022.3143030).
- [19] F. Nikbakhtnasrabadi, E. S. Hosseini, S. Dervin, D. Shakthivel, and R. Dahiya, "Inductor-Capacitor Resonant Tank based Printed Wireless Pressure Sensor for Online Health Monitoring," *Advanced Electronic Materials*, 2022, doi: [10.1002/aelm.202101348](https://doi.org/10.1002/aelm.202101348).
- [20] J. R. Montejo-Garai, J. A. Ruiz-Cruz, and J. M. Rebollar, "Additive manufacturing of a compact Ku-band orthomode transducer," *AEU - International Journal of Electronics and Communications*, vol. 137, p. 153798, 2021.
- [21] L. A. K. de Andrade and E. F. Manfra, "An additive manufacturing fabricated a split Pitot tube transducer for mechanical ventilator analyzers," *Research on Biomedical Engineering*, 2021.
- [22] J. A. Lewis, "Direct Ink Writing of 3D Functional Materials," *Advanced Functional Materials*, vol. 16, no. 17, pp. 2193-2204, 2006.
- [23] H. Nassar and R. Dahiya, "Fused Deposition Modeling-Based 3D-Printed Electrical Interconnects and Circuits," *Advanced Intelligent Systems*, vol. 3, no. 12, p. 2100102, 2021.
- [24] J. I. Yoon, K. S. Choi, and S. P. Chang, "A novel means of fabricating microporous structures for the dielectric layers of capacitive pressure sensor," *Microelectronic Engineering*, vol. 179, pp. 60-66, 2017.
- [25] S. H. Kim, J.-H. Moon, J. H. Kim, S. M. Jeong, and S.-H. Lee, "Flexible, stretchable and implantable PDMS encapsulated cable for implantable medical device," *Biomedical Engineering Letters*, vol. 1, no. 3, p. 199, 2011.
- [26] J. Hwang, Y. Kim, H. Yang, and J. H. Oh, "Fabrication of hierarchically porous structured PDMS composites and their application as a flexible capacitive pressure sensor," *Composites Part B: Engineering*, vol. 211, p. 108607, 2021.
- [27] R. Dahiya, W. T. Navaraj, S. Khan, and E. O. Polat, "Developing Electronic Skin with the Sense of Touch," *Information Display*, vol. 31, no. 4, pp. 6-10, 2015.
- [28] C.-R. Yang, L.-J. Wang, and S.-F. Tseng, "Arrayed porous polydimethylsiloxane/barium titanate microstructures for high-sensitivity flexible capacitive pressure sensors," *Ceramics International*, 2022, doi: <https://doi.org/10.1016/j.ceramint.2022.01.191>.
- [29] B. You, C. J. Han, Y. Kim, B.-K. Ju, and J.-W. Kim, "A wearable piezocapacitive pressure sensor with a single layer of silver nanowire-based elastomeric composite electrodes," *Journal of Materials Chemistry A*, vol. 4, no. 27, pp. 10435-10443, 2016.
- [30] S. Masihi et al., "Highly Sensitive Porous PDMS-Based Capacitive Pressure Sensors Fabricated on Fabric Platform for Wearable Applications," *ACS Sensors*, vol. 6, no. 3, pp. 938-949, 2021.
- [31] C. Parameswaran and D. Gupta, "Low cost sponge based piezocapacitive sensors using a single step leavening agent mediated autolysis process," *Journal of Materials Chemistry C*, vol. 6, no. 20, pp. 5473-5481, 2018.
- [32] E. S. Hosseini, M. Chakraborty, and R. Dahiya, "Porous Elastomer based Wide Range Flexible Pressure Sensor Device for Autonomous Underwater Vehicles," *IEEE Sensors Journal*, 2022.
- [33] C. A. Charitidis, E. P. Koumoulos, V. P. Tsikourkitoudi, D. A. Dragatogiannis, and G. Lolas, "Influence of accelerated aging on nanomechanical properties, creep behaviour and adhesive forces of PDMS," *Plastics, Rubber and Composites*, vol. 41, no. 2, pp. 94-99, 2012.
- [34] F. Wang, Y. Tan, H. Peng, F. Meng, and X. Yao, "Investigations on the preparation and properties of high-sensitive BaTiO₃/MwCNTs/PDMS flexible capacitive pressure sensor," *Materials Letters*, vol. 303, p. 130512, 2021.
- [35] Y. Zhuang et al., "Preparation and laser sintering of a thermoplastic polyurethane carbon nanotube composite-based pressure sensor," *RSC Advances*, vol. 10, no. 40, pp. 23644-23652, 2020.
- [36] X. Chen et al., "High-sensitivity, fast-response flexible pressure sensor for electronic skin using direct writing printing," *RSC Advances*, vol. 10, no. 44, pp. 26188-26196, 2020.
- [37] S.-W. Dai et al., "Bamboo-inspired mechanically flexible and electrically conductive polydimethylsiloxane foam materials with designed hierarchical pore structures for ultra-sensitive and reliable piezoresistive pressure sensor," *Composites Part B: Engineering*, vol. 225, p. 109243, 2021.
- [38] Bijender and A. Kumar, "One-Rupe Ultrasensitive Wearable Flexible Low-Pressure Sensor," *ACS Omega*, vol. 5, no. 27, pp. 16944-16950, 2020.
- [39] G. Shi et al., "A versatile PDMS submicrobead/graphene oxide nanocomposite ink for the direct ink writing of wearable micron-scale tactile sensors," *Applied Materials Today*, vol. 16, pp. 482-492, 2019.